



Dkt. 06080

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

PCT

WERNER BENSCH

Serial No.: 10/586,946

Filed: July 25, 2006

For: SEMICONDUCTOR STRUCTURE COMPRISING ACTIVE ZONES

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Applicant submits herewith a copy of a reference for consideration by the Examiner, which is listed on the attached Form PTO-1449.

Respectfully submitted,

Malcolm J. MacDonald
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /S.H./

Form PTO-1449		ATTY DOCKET NO. 0608095		APPLICATION NO. 10/586, 946			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		APPLICANT Werner Bensch					
(Use several sheets if necessary)		FILING DATE July 25, 2006		GROUP PCT			
U. S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
						YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
		Contour et al, "(GaAl) As Tunnel Junctions Grown by Molecular Beam Epitaxy: Intercell OHMIC Contacts for multiple-Band-Gap Solar Cells" Solar Cells Switzerland, 1984, pp. 667-76.					
EXAMINER /Shouxiang Hu/		DATE CONSIDERED		01/30/2009			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /S.H./